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**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant: H. Miura, et al.

Application No.: 09/254,939

Filing Date: March 17, 1999

For: METHOD OF FABRICATING SEMICONDUCTOR DEVICE HAVING  
TRENCH ELEMENT SEPARATION STRUCTURE

Art Unit: 2814

Examiner: Anh D. Mai

**AMENDMENT**

Mail Stop: Amendment (Fee)  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

March 23, 2004

Sir:

In response to the Office Action mailed December 23, 2003, please amend the above-identified application as listed in the following, and as set forth on the following pages:

Amendments to the Claims; and

Remarks are included following the amendments.

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